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Origin and Reduction of 1/f Magnetic Flux Noise in Superconducting Devices

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Magnetic flux noise is a dominant source of dephasing and energy relaxation in superconducting qubits. The noise power spectral density varies with frequency as 1/f^\alpha, with \alpha \lesssim 1, and spans 13 orders of magnitude. Recent work indicates that the noise is from unpaired magnetic defects on the surfaces of the superconducting devices. Here, we demonstrate that adsorbed molecular O_2 is the dominant contributor to magnetism in superconducting thin films. We show that this magnetism can be reduced by appropriate surface treatment or improvement in the sample vacuum environment. We observe a suppression of static spin susceptibility by more than an order of magnitude and a suppression of 1/f magnetic flux noise power spectral density of up to a factor of 5. These advances open the door to the realization of superconducting qubits with improved quantum coherence.

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Low-frequency 1/f magnetic flux noise was first identified in the 1980s when superconducting quantum interference device (SQUID) circuits were cooled to millikelvin temperatures in an effort to reach quantum-limited sensitivity for applications such as gravity-wave detection [1]. While the white noise level of these devices decreases as expected with decreasing temperature, an excess low-frequency flux noise persists to the lowest temperatures. The flux noise power spectral density scales with frequency as 1/f^\alpha with \alpha \lesssim 1; interestingly, the magnitude of this excess noise is roughly independent of device scale and materials [1]. At the time, many noise sources were ruled out; however, the microscopic origin of the noise was never identified. The source of flux noise has remained a longstanding puzzle in condensed matter physics [2].

More recently, it has been realized that this noise is a dominant source of dephasing in superconducting quantum bits (“qubits”) [3–5], a leading candidate for scalable quantum information processing in the solid state [6–8]. In the context of a quantum annealer [9,10], flux noise degrades performance by limiting the number of qubits that can tunnel coherently. For these reasons, there is strong motivation to understand and eliminate the flux noise.

Recent experiments indicate that there is a high density of unpaired surface spins in superconducting integrated circuits [11], and it is now believed that fluctuations of these spins give rise to the 1/f flux noise [12–14]. There is experimental evidence that interactions between the surface spins are significant [15]. To date, however, there has been no experimental data pointing toward the microscopic nature of the surface magnetic defects, although there has been speculation that the defects are due to localized states at the disordered metal-insulator interface [16] or to surface adsorbates [17], molecular O_2 in particular [13].

Here, we describe x-ray absorption spectroscopy (XAS) and x-ray magnetic circular dichroism (XMCD) experiments that point to adsorbed molecular O_2 as the dominant source of surface magnetism in superconducting thin films. We show that improvement of the vacuum environment of the superconducting sample and appropriate surface passivation can dramatically reduce the surface density of spins in superconducting thin films. We present data on the surface spin susceptibility and magnetic flux noise of devices before and after various surface treatments and demonstrate a significant suppression of magnetic activity and flux noise power. Our results rule out prevailing theoretical models that invoke localized defects at the metal-insulator interface [16] that interact via the Ruderman-Kittel-Kasuya-Yosida mechanism [12]. Moreover, the implication of an extrinsic noise source provides a natural explanation for the observed weak dependence of the noise on device materials [1]. The achieved noise reduction opens the door to development of improved qubits with extended coherence times.

Using the Advanced Photon Source at Argonne National Laboratory, we perform XAS and XMCD experiments on...
aluminum and niobium thin-film samples. In XMCD, one monitors the absorption of a spin-polarized sample at specific x-ray edges; the x-ray energy provides elemental specificity, while the x-ray helicity provides access to orbital magnetism. Devices are cooled to 10 K, and XMCD experiments are performed in fields of up to 5 T. Initially, we examine sputtered Al and Nb films cooled in ultrahigh vacuum (UHV; \( P \lesssim 10^{-9} \) Torr); we expect these films to be covered by an amorphous native oxide due to prolonged exposure to atmosphere. We examine the Al and O K edges in the Al films and the Nb L edge and the O K edge in the Nb films and observe no XMCD signal at any of these energies [Fig. 1(a), upper trace]. However, when we intentionally degrade the vacuum of the sample

FIG. 1. (a) X-ray magnetic circular dichroism (XMCD) at the oxygen K edge for a native Al film and an Al film exposed to air. The native film (top) shows no XMCD signal, while the air-exposed film (bottom) shows a clear XMCD signal at 531 eV. (Traces are offset for clarity.) A similar XMCD signal at the oxygen K edge is seen for Nb films exposed to air (not shown). (b) Oxygen K-edge x-ray absorption spectroscopy (XAS) of an Al thin film cooled in the presence of \( 5 \times 10^{-8} \) Torr O\(_2\). Beginning at around 45 K, we observe a sharp peak at 531 eV and a broad spectral feature from 535–550 eV which we ascribe to adsorbed molecular O\(_2\). (Traces are offset for clarity.) Dashed lines are from DFT simulations for Al\(_2\)O\(_3\) (XAS at 50 K) and for O\(_2/\)Al\(_2\)O\(_3\) (XMCD and XAS at 10 K); see the Supplemental Material [18] for details.

The XMCD results suggest that the dominant magnetism in Al and Nb thin films of the type used to make qubit circuits is due not to a high density of intrinsic defects, but rather to adsorbed molecular O\(_2\). The outermost electrons of the O\(_2\) molecule form a spin-1 triplet state [13]. O\(_2\) is paramagnetic at high temperatures; at low temperatures, solid molecular O\(_2\) displays a complex phase diagram with multiple competing magnetic orders [19]. In typical superconducting qubit experiments, devices are cooled to millikelvin temperatures in vacuum cryostats that achieve pressures on the order of \( 10^{-6} \) Torr prior to cooldown; this pressure corresponds to an adsorption rate of roughly 1 ML/s, assuming a unit sticking coefficient. Even when the cryostat is cold, there is a continual flux of molecules from hot regions of the cryostat to the cold regions where the sample is housed. Thus, an accumulation of magnetic O\(_2\) on the surface of these devices is inevitable.

This realization motivates us to attempt noise reduction by improving the vacuum environment of the superconducting devices. To this end, we have designed a hermetic sample enclosure based on grade 5 titanium alloy (Ti-6Al-4V); see the Supplemental Material [18]. In Fig. 2 we show the details of the enclosure and the sample prep chamber. The sample box is pumped through a copper pinch tube with a turbomolecular pump and an ion pump. During evacuation, the sample enclosure and chamber are baked to 120°C. Following vacuum bake, the sample cell is cooled to room temperature and the cell is hermetically sealed using a commercial pinch tool. In some cases, the sample cell is backfilled with NH\(_3\) gas prior to pinch-off. In other
cases, the sample is irradiated with UV light (365 nm) during evacuation to promote photodesorption of strongly bound magnetic species, and a nonevaporable getter (NEG) pill (SAES, Inc.) is activated in a separate chamber and transferred into the sample enclosure under vacuum. The NEG provides continuous pumping in the sample cell following pinch-off.

In the first series of experiments, we characterize the surface spin density on washer-style Nb SQUIDs by monitoring the temperature-dependent zero-frequency surface spin susceptibility of field-cooled devices [11]. The device layout is shown in the inset of Fig. 3. Here, we intentionally trap flux vortices in the thin films of the Nb SQUID by cooling through the superconducting transition in the presence of an applied magnetic field. Any unpaired magnetic defects on the surface of the device develop a thermal polarization in the relatively strong (tens of mT) local fields in the vortex core. As temperature decreases, the thermal polarization of the defect spins increases. The flux through the SQUID loop thus displays a roughly $1/T$ Curie-like dependence on temperature, and the measured flux change can be used to extract a surface density of unpaired spins. For typical devices, we infer a surface spin density on the order of $10^{17}$ m$^{-2}$ [11,20].

In Fig. 3 we compare baseline data to data from a cell that is evacuated and then backfilled with NH$_3$ gas at approximately 100 Torr prior to pinch-off. The temperature-dependent flux is suppressed by roughly an order of magnitude. Nonmagnetic NH$_3$ has a higher free energy of adsorption than O$_2$ (1.5 versus 0.15 eV according to our DFT calculations on Al$_2$O$_3$). Hence, it occupies available surface sites that would otherwise be taken up by magnetic O$_2$, resulting in a suppression of the surface density of adsorbed spins; related approaches to suppressing magnetic adsorbates were suggested in Refs. [13,17].

Both susceptibility and magnetization noise scale linearly with spin density, and reduction in the density of surface spins should yield a reduction in flux noise power. In the final series of experiments, we have examined the flux noise of Al-based SQUIDs subjected to various surface treatments; the results are presented in Fig. 4 and Table I. In these experiments, the Al-based first-stage device under test (DUT) is biased with a voltage, and the fluctuating current through the DUT is measured with a second Nb-based SQUID; measurements are performed in an adiabatic demagnetization refrigerator at a temperature of 100 mK. We characterize devices where the SQUID loop is encapsulated either in SiN$_x$ or SiO$_x$ grown by plasma-enhanced chemical vapor deposition. The SQUIDs described here are designed with a relatively high loop aspect ratio (ratio of loop width to trace width) of 25, as this geometry enhances the coupling of surface spin fluctuations to the device [5,14,21] (see the Supplemental Material [18]). We fit the measured noise spectra to the form $A/f^\alpha + B$, and we compare the $1/f$ noise power $A$ and noise exponent $\alpha$ measured on identical devices before and after surface treatment.

In the case of SQUIDs encapsulated in SiN$_x$, we observe a significant noise reduction for both devices passivated with NH$_3$ and devices cooled in an improved vacuum following UV illumination. Figure 4(a) shows before and after spectra from one sample that was baked in the titanium cell and passivated with NH$_3$ using the protocol described above. The flux noise power spectral density at 1 Hz decreases from 8.2 to $1.6 \mu \Phi_0^2$/Hz. In Fig. 4(b) we show before and after spectra from a device that was subjected to UV illumination and cooled in an improved vacuum; here, the flux noise power spectral density at 1 Hz decreases from 1.7 to 0.35 $\mu \Phi_0^2$/Hz. We examine a total of six SiN$_x$-encapsulated devices; the results are summarized in the table. For these devices, we observe a magnetic flux noise level of $3.9 \pm 2.2 \mu \Phi_0^2$/Hz at 1 Hz prior to
surface treatment, with the noise exponent $\alpha = 0.95 \pm 0.17$. Following treatment, we find a noise level $1.7 \pm 1.0 \, \mu\Phi_0^2/\text{Hz}$ at 1 Hz with the noise exponent $\alpha = 0.83 \pm 0.18$. A noise reduction is seen in every SiN$_x$-encapsulated device, with an average reduction in $S_\Phi (1 \, \text{Hz})$ by a factor of 2.8 and a maximum noise reduction by a factor of 5.1. We remark that repeated noise measurements on individual devices (even following thermal cycle to 300 K) show very little variation in the absence of surface modification (see the Supplemental Material [18]); the robustness of the noise spectrum to thermal cycling suggests that fixed disorder at the surface dictates how the O$_2$ molecules are adsorbed or, alternatively, that strongly bound magnetic species persist to high temperatures, providing a noise “fingerprint”. To our knowledge, the $1/f$ flux noise measured in our surface-treated nitride devices is the lowest reported in the literature, when the noise is appropriately scaled by device aspect ratio.

In the case of SiO$_x$-encapsulated devices subjected to UV irradiation under vacuum, no clear noise suppression is seen. We speculate that the UV photon energy of 3.4 eV is large enough to break bonds in the encapsulating oxide, perhaps liberating additional oxygen and providing another path for magnetic contamination.

Our ability to reduce $1/f$ flux noise power by up to a factor of 5 indicates clearly that adsorbates are the dominant source of low-frequency flux noise in our devices. It is reasonable to ask why the noise reduction is not larger. It could be that the remaining noise is still dominated by residual adsorbates. We measure pressure in the $10^{-9}$ Torr range at the ion pump, and pressure in the cell is likely an order of magnitude higher. Improvements in vacuum could lead to further noise reduction. Once again, the suppression of static spin susceptibility in the Nb SQUID described in Fig. 3 is larger than the noise reductions in Al-based devices described in Fig. 4 and Table I. This discrepancy suggests that the details of the disordered surface play a critical role in dictating the adsorption and/or fluctuation dynamics of the O$_2$ moments. We do measure systematically higher flux noise in oxide-encapsulated devices, and we have seen an increase in the flux noise of the nitride-encapsulated devices over the course of several years prior to this investigation of surface treatments, presumably due to uncontrolled evolution of the disordered surface; see the Supplemental Material [18]. Alternatively, it could be that the residual noise is due to some other magnetic states that are immune to the surface treatments described here.

Our DFT calculations indicate that an O$_2$ molecule adsorbed on Al$_2$O$_3$ (0001) sits atop Al atoms and has a moment of $1.8\mu_B$ that rotates almost freely in the plane perpendicular to the molecular axis (with a barrier to spin rotation of approximately 10 mK) [13,22–24]. $1/f$ noise results from a distribution of relaxation times [25] that can arise from interactions. DFT finds that neighboring O$_2$ molecules on Al$_2$O$_3$ have ferromagnetic exchange, and Monte Carlo simulations show that a distribution of ferromagnetic interactions produces $1/f$ noise consistent with experiment [13]. Surface disorder could change the magnitude and sign of these interactions, affecting the noise exponent; these questions are the focus of ongoing research.

### TABLE I. Noise reduction by vacuum and surface treatment.

The table includes results of before and after measurements on six SQUIDs with SiN$_x$ loop encapsulation (SiN$_x = 1, \ldots, 6$) and four SQUIDs with SiO$_x$ loop encapsulation (SiO$_x = 1, \ldots, 4$). Relative uncertainties in flux noise power spectral density $S_\Phi (1 \, \text{Hz})$ and noise exponent $\alpha$ are 10% and 25%, respectively, as determined from repeated measurements following thermal cycling (see the Supplemental Material [18]).

<table>
<thead>
<tr>
<th>Device</th>
<th>$S_\Phi (1 , \text{Hz})$</th>
<th>$\alpha$</th>
<th>Pretreatment</th>
<th>Post-treatment</th>
</tr>
</thead>
<tbody>
<tr>
<td>SiN$_x = 1$</td>
<td>2.0</td>
<td>1.0</td>
<td>UHV</td>
<td>1.4</td>
</tr>
<tr>
<td>SiN$_x = 2$</td>
<td>4.4</td>
<td>0.7</td>
<td>NH$_3$</td>
<td>2.4</td>
</tr>
<tr>
<td>SiN$_x = 3$</td>
<td>2.8</td>
<td>1.0</td>
<td>UHV, UV</td>
<td>1.3</td>
</tr>
<tr>
<td>SiN$_x = 4$</td>
<td>8.2</td>
<td>1.2</td>
<td>NH$_3$</td>
<td>1.6</td>
</tr>
<tr>
<td>SiN$_x = 5$</td>
<td>4.1</td>
<td>0.8</td>
<td>UHV, UV</td>
<td>4.2</td>
</tr>
<tr>
<td>SiN$_x = 6$</td>
<td>1.7</td>
<td>1.0</td>
<td>NH$_3$</td>
<td>1.7</td>
</tr>
<tr>
<td>SiO$_x = 1$</td>
<td>13.4</td>
<td>0.5</td>
<td>UHV, UV</td>
<td>13.7</td>
</tr>
<tr>
<td>SiO$_x = 2$</td>
<td>6.5</td>
<td>1.0</td>
<td>UHV, UV</td>
<td>2.5</td>
</tr>
<tr>
<td>SiO$_x = 3$</td>
<td>4.8</td>
<td>0.7</td>
<td>UHV, UV</td>
<td>5.1</td>
</tr>
<tr>
<td>SiO$_x = 4$</td>
<td>3.0</td>
<td>0.8</td>
<td>UHV, UV</td>
<td>5.4</td>
</tr>
</tbody>
</table>
In summary, we find that adsorbed molecular O\textsubscript{2} is a dominant source of magnetism in superconducting devices. The identification of an extrinsic noise source explains the weak dependence of 1/f flux noise on device materials and invalidates prevailing theories for the noise based on defects at the metal-insulator interface. Suitable surface passivation and improvements in the sample vacuum environment lead to significant reductions in spin susceptibility and low-frequency flux noise. These developments open the door to the development of frequency-tunable superconducting qubits with improved dephasing times.

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